

Docket No.: K-243

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
: Si Wook HAN and Sang Mun KIM :
: Serial No. New U.S. Patent Application :
: Filed: December 12, 2000 :
: For: FIELD EMISSION DISPLAY AND METHOD FOR FABRICATING :
THE SAME :

1c862 U.S. PRO
09/733952
12/12/00

AUTHORIZATION TO TREAT A REPLY AS INCORPORATING
AN EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a)(3)

Assistant Commissioner for Patents
Washington, D. C. 20231

Sir:

The U.S. Patent and Trademark Office is hereby authorized to treat any concurrent or future reply that requires a petition for an extension of time under this paragraph for its timely submission, as incorporating a petition for extension of time for the appropriate length of time under 37 C.F.R. 1.136(a)(3). The U.S. Patent and Trademark Office is hereby authorized to charge all required extension of time fees to our Deposit Account No. 16-0607, if such fees are not otherwise provided for in such reply. A duplicate copy of this sheet is enclosed.

Respectfully submitted,
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